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Serial Number: 10708509

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US 20060175303 A1	20060810	PROCESS OF MAKING A MICROTUBE AND MICROFLUIDIC DEVICES FORMED THEREWITH	219/121.43		Sparks; Douglas Ray et al.
US 20060169038 A1	20060803	FLUID SENSING DEVICE WITH INTEGRATED BYPASS AND PROCESS THEREFOR	73/202		Sparks; Douglas Ray et al.
US 20060047205 A1	20060302	DELIVERY METHOD AND SYSTEM FOR MONITORING CARDIOVASCULAR PRESSURES	600/486		Ludomirsky; Achiau et al.
US 20060037187 A1	20060223	PROCESS OF MAKING A MICROTUBE AND MICROFLUIDIC DEVICES FORMED THEREWITH	29/592.1	73/204.26; 73/861.351	Sparks; Douglas Ray et al.
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US 20050284815 A1	20051229	MEDICAL TREATMENT SYSTEM AND METHOD	210/645	210/646; 210/742; 604/4.01; 604/65	Sparks, Douglas Ray et al.
US 20050235759 A1	20051027	DRUG-SPECIFIC FLUID DELIVERY SYSTEM	73/861.352		Sparks, Douglas Ray et al.
US 20050126304 A1	20050616	FLUID INFUSION METHOD AND SYSTEM THEREFOR	73/861.05		Sparks, Douglas Ray et al.
US 20050065589 A1	20050324	Method and anchor for medical implant placement, and method of anchor manufacture	607/126		Schneider, Richard Lee et al.
US 20040255648 A1	20041223	RESONANT TUBE VISCOSITY SENSING DEVICE	73/54.41		Sparks, Douglas Ray

US 20040171983 A1	20040902	FLUID DELIVERY SYSTEM AND SENSING UNIT THEREFOR	604/65	128/DIG.13	Sparks, Douglas R. et al.
US 20030159741 A1	20030828	FLUID DELIVERY SYSTEM AND METHOD	137/814	604/67	Sparks, Douglas Ray
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US 20020194908 A1	20021226	Integrated microtube sensing device	73/204.26		Sparks, Douglas Ray
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US 20020115920 A1	20020822	MEMS capacitive sensor for physiologic parameter measurement	600/345	600/485; 600/549	Rich, Collin A. et al.
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